



ELECTRONIC COPY

LG800638700
Report verification at igi.org



May 12, 2026

IGI Report Number **LG800638700**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.53 - 6.57 X 3.97 MM**

GRADING RESULTS

Carat Weight **1.02 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

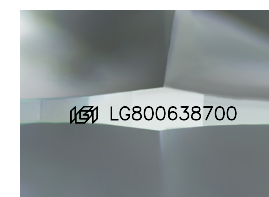
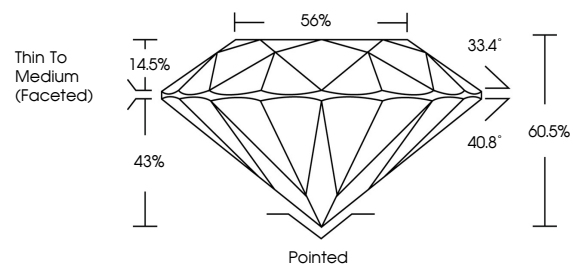
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG800638700**

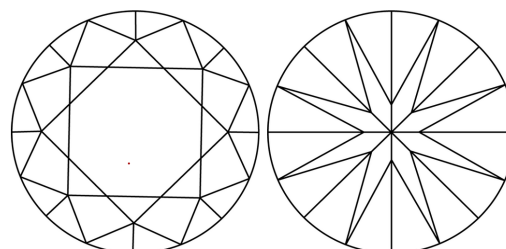
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

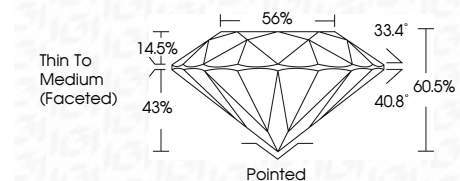
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



ADDITIONAL GRADING INFORMATION

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Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



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ROUND BRILLIANT	6.53 - 6.57 X 3.97 MM	Color Grade	VVS 2	Depth	43%	Crown Angle	33.4°	IGI LG800638700
		Clarity Grade	IDEAL	Table	56%	Pavilion Angle	40.8°	
		Cut Grade	IDEAL	Thin to Medium (Faceted)	14.5%			
		Polish	EXCELLENT					
		Symmetry	EXCELLENT					
		Fluorescence	NONE					
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